

DO NOT ENTER



Attorney Docket No. 0756-7275

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Hidekazu MIYAIRI et al.

Serial No. 10/808,499

Filed: March 25, 2004

For: METHOD FOR TESTING

SEMICONDUCTOR FILM,

SEMICONDUCTOR DEVICE AND

MANUFACTURING METHOD

THEREOF

) Group Art Unit: 2857

) Examiner: J. West

) CERTIFICATE OF MAILING

) I hereby certify that this correspondence is
) being deposited with the United States Postal
) Service with sufficient postage as First Class
) Mail in an envelope addressed to:
) Commissioner for Patents, P.O. Box 1450,
) Alexandria, VA 22313-1450, on January 21,
) 2009.

) Adrian M. Stanger

)

AMENDMENT

Honorable Commissioner of Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

In response to the Official Action dated August 19, 2008, please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks begin on page 11 of this paper.